

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/092,874
Confirmation No. 9983
Filing Date March 5, 2002
Inventor Y. Hishiro
Assignee Micron Technology, Inc.
Group Art Unit 2814
Examiner G. Peralta
Attorney's Docket No. MI22-1873
Customer No. 021567
Title: Methods Of Forming Semiconductor Constructions

RESPONSE TO JUNE 6, 2003 OFFICE ACTION

To: Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS**FAX RECEIVED****AUG 20 2003****GROUP 2800**

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